



HITACHI

Global Laser Enrichment

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**Security-related Information Notice**

*This letter forwards security-related sensitive information which is to be withheld from public disclosure in accordance with 10CFR2.390. The balance of this letter may be considered non-sensitive upon the removal of Enclosure 1.*

LMQ-09-018  
April 7, 2009

Attn: Document Control Desk  
Director, Division of Security Operations  
Office of Nuclear Security and Incident Response  
U.S. Nuclear Regulatory Commission  
Washington, D.C. 20555-0001

Subject: **GLE Facility Change Supporting Information and Approval Request**

Dear Sirs:

GE-Hitachi Global Laser Enrichment LLC (GLE) hereby submits information supporting our earlier Reference 2 request for approval of certain classified information activities as identified in Enclosure 1 to this letter. These changes and supporting information were previously discussed with Mr. J. K. Everly. **Enclosure 1 of this letter contain security-related sensitive information which is to be withheld from public disclosure in accordance with 10 CFR 2.390 and the instructions in RIS 2005-31.**

If there are any questions regarding these changes and requests, please do not hesitate to contact Mr. Matthew G. Allen at 910-819-6200 or the undersigned.

Sincerely,

Louis M. Quintana  
U Enrichment Licensing

References: 1) U.S. NRC License No. SNM-1097, Docket No. 70-1113.  
2) Letter, L.M. Quintana (GEH) to Document Control Desk (NRC), "Revision 10 of Standard Practice Procedures Plan for GLE", March 3, 2009.

Enclosures:

1. "GLE Facility Change Supporting Information and Approval Request" (*contains security-related sensitive information*)

U.S. NRC Document Control Desk

LMQ-09-018

April 7, 2009

Page 2 of 2

cc: M. G. Allen (GEH)

M. N. Baker (NRC)

J. R. Earnhart (GLE)

J. K. Everly (NRC)

M. V. Robertson (GEH)

LMQ-09-018